Report verification at igi.org

Very Light

Light

LG596353065

EMERALD CUT 15.14 X 10.45 X 6.69 MM

(例 LG596353065

DIAMOND

LABORATORY GROWN

October 28, 2023

IGI Report Number

Shape and Cutting Style

Description

Measurements **GRADING RESULTS** 

Inscription(s)

# **ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

October 28, 2023

IGI Report Number

LG596353065

**EMERALD CUT** 

G

Description

Measurements

LABORATORY GROWN DIAMOND

Shape and Cutting Style

15.14 X 10.45 X 6.69 MM

# **GRADING RESULTS**

Carat Weight 10.10 CARATS

Color Grade

Clarity Grade VS 1

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT** 

**EXCELLENT** Symmetry

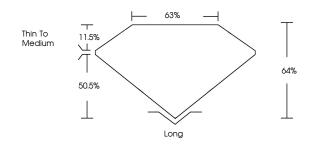
NONE Fluorescence

Inscription(s) 151 LG596353065

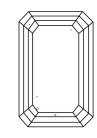
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment.

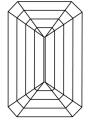
Type IIa

### **PROPORTIONS**



#### **CLARITY CHARACTERISTICS**





#### **KEY TO SYMBOLS**

Red symbols indicate internal characteristics. Green symbols indicate external characteristics.

#### **GRADING SCALES**

DEFGHIJ

#### CLARITY

| IF                     | VVS <sup>1-2</sup>             | VS <sup>1-2</sup>         | SI 1-2               | I <sup>1-3</sup> |
|------------------------|--------------------------------|---------------------------|----------------------|------------------|
| Internally<br>Flawless | Very Very<br>Slightly Included | Very<br>Slightly Included | Slightly<br>Included | Included         |
| COLOR                  |                                |                           |                      |                  |

Faint



Sample Image Used



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FD - 10 20



Carat Weight 10.10 CARATS Color Grade Clarity Grade VS 1 63% Thin To Medium 64% 50.5%

#### ADDITIONAL GRADING INFORMATION

| Polish       | EXCELLEN |
|--------------|----------|
| Symmetry     | EXCELLEN |
| Fluorescence | NONI     |

Long

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment.





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